

Attorney Docket No. SEE 174

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Shunpei YAMAZAKI et al.

Serial No.: 09/544,801

Filed: April 7, 2000

Art Unit: 2826

For: Semiconductor Device And Method
For Fabricating The Same

) I hereby certify that this correspondence
) is being deposited with the United States
) Postal Service as first class mail in an
) envelope addressed to:
) Commissioner for Patents, Washington,
) D.C. 20231, on April 18, 2002

) Kim L. Guly
)
)

) 4-18-02
)
) Date: 4-18-02

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992, 1135 OG 23-24, Applicant hereby call the Examiner's attention to documents listed on the attached form, which documents may be material to the examination of this application. A copy of each of the documents is enclosed herewith for the Examiner's consideration.

Other applications related to the present invention include:

US Patent Application No. 09/528,113 (pending)

US Patent Application No. 09/533,040 (issue fee)

US Patent Application No. 09/559,185 (pending)

No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

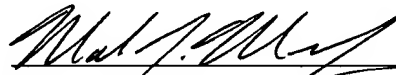
The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not

to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

Please charge our Deposit Account No. 50/1039 for the amount for this IDS.

Respectfully submitted,



Mark J. Murphy

Registration No. 34,225

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LIST OF PUBLICATIONS CITED BY APPLICANT			<u>Attorney Docket No.</u> SEL 174		<u>Serial No.</u> 09/544,801	
			<u>Applicant</u> Shunpei YAMAZAKI et al.			
			<u>Filing Date</u> April 7, 2000		<u>Group</u>	
U.S. PATENT DOCUMENTS						
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
OTHER PUBLICATIONS (Including Author, Title, Date, Pertinent Pages)						
	1) US Patent Application No. 09/528,113 (pending) to Yamazaki et al. including PTO filing receipt, claims, specification, abstract, and drawings. 2) US Patent Application No. 09/533,040 (issue fee) to Yamazaki including PTO filing receipt, specification, claims, abstract, drawings, and allowed claims. 3) US Patent Application No. 09/559,185 (pending) to Yamazaki including PTO filing receipt, specification, claims, abstract, drawings, and pending claims as of April 9, 2002.					
EXAMINER:				DATE CONSIDERED:		
*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.						

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